

L Number	Hits	Search Text	DB	Time stamp
1	3467	etch\$3 same ((rectangular or rectangle or square) with (substrate\$1 or wafer\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/09/25 16:57
15	366	((etch\$3 same ((rectangular or rectangle or square) with (substrate\$1 or wafer\$1))) and ((uniformity or uniform) with etch\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/09/25 16:58
22	70	((etch\$3 same ((rectangular or rectangle or square) with (substrate\$1 or wafer\$1))) and ((uniformity or uniform) with etch\$3)) and ((second adj4 power) or (second adj4 electrode))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/09/25 17:00

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